FORM PTO-1449			Docket Number (Optional) 88519.0003		Application Number Not assigned	
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)			Applicant Ken NAKAHARA			
			Filling Date February 4, 2004		Group Art Unit Not assigned	
	ļ	U.S. PATEN	T DOCUMENTS			
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
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	FO	REIGN PAT	ENT DOCUMENTS)		
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION (YES/NO)
Me	2002-118330	04/19/02	Japan			Abstract
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	OTHER DOCUMENTS	S (including Au	ithor, Title, Date, Pert	inent Pages,	Etc.)	····································
M	Soon-Ku Hong et al., "Control of pola ZnO films on Ga-polar GaN template					
	D.C. Look et al., "Characterization of Vol. 81, No. 10, September 2, 2002,	homoepitaxial pp. 1830-1832.	p-type ZnO grown by m	olecular bean	n epitaxy", Appli	ed Physics Letters,
<i>7</i>					•	
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EXAMINER	Confo	ATE CONSIDE	RED 6/21/0	15		
EXAMINER: II	nitial if citation considered, whether or r	not citation is in	conformance with MPE	P § 609; Drav	w line through ci	tation if not in